

Electronic Patent Application Fee Transmittal

Application Number:	10804053			
Filing Date:	19-Mar-2004			
Title of Invention:	Film formation method and manufacturing method of semiconductor device			
First Named Inventor/Applicant Name:	Mitsuhiro Ichijo			
Filer:	Carlos Rafael Villamar/Kisha Avery			
Attorney Docket Number:	740756-2718			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 2 months with \$0 paid	1252	1	450	450

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				1240